

20/ Req. for recon
V. Pri
3/21/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of)
) Atty. Docket No.: TM&K0004
Shinji TAKEDA et al.)
)
Serial No. 09/543,247) Group Art Unit: 2814
)
Filed: April 5, 2000)
) Examiner: David E. Graybill
For: SEMICONDUCTOR DEVICE AND)
PROCESS FOR FABRICATION)
THEREOF) Date: December 2, 2002

RESPONSE (C) AFTER FINAL

BOX: AFTER FINAL
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the official Final Office Action dated June 6, 2002 regarding the above captioned application, Applicants make the following remarks.

REMARKS

As an initial matter, Applicants have submitted herewith a certified English translation of Japanese priority document 7-171154, filed July 6, 1995 in Japan. The USPTO has already received a certified copy of the original document (see Office Action Summary, Office Action dated September 10, 2001), and Applicants have properly claimed priority to Japanese document 7-171154, thereby perfecting a priority date of July 6, 1995 for the present application in accordance with 37 C.F.R. 1.55.